AMENDMENTS TO THE CLAIMS

This listing of the claims will replace all prior versions and listings of the claims in this application.

LISTING OF THE CLAIMS:

- 1. (Currently amended) A strain sensor which consists of a polymer that has been irradiated with less than $1x10^{15}$ ions /cm² in a portion of its surface to produce exhibit strain dependent electrical properties for producing a measurable electrical signal that is linear with increasing strain, with conducting tracks being deposited onto the treated portion to enable the sensor to be connected to an external electric circuit.
- 2. (Original) A strain sensor as claimed in claim 1 in which the polymer is a polyimide film.
- 3. (Currently amended) A method of forming a strain sensor from a polymeric film which includes the steps of selectively irradiating a surface of the polymer with high energy radiation at an intensity less than $1x10^{15}$ ions /cm² to produce exhibit strain dependent electrical properties in selected portions of the surface for producing a measurable electrical signal that is linear with increasing strain.
- 4. (Original) A method as claimed in claim 3 in which the high energy radiation carbonizes the polymer to form conductive particles in the polymer.
- 5. (Original) A method as claimed in claim 3 in which high energy ions impinge on a polymer film containing precursor metal compounds, such that decomposition of the precursor leads to nucleation of conducting metal particles.
- 6. (Previously presented) A method as claimed in claim 3 in which the polymer is a polyimide.

Application No. 10/599,894 Docket No.: 21854-00075-US1 Amendment dated May 11, 2008

Reply to Office Action of February 11, 2008

7. (Previously presented) A method as claimed in claim 3 in which conducting tracks are deposited onto the treated polymer to enable the device to be connected to an external electric circuit.

8. (Currently amended) A strain sensor made by the method of claim 3.